

Title (en)
PROCESS FOR THE MECHANICAL CLASSIFYING OF POLYSILICON

Title (de)
VERFAHREN ZUM MECHANISCHEN KLASSIEREN VON POLYSILICIUM

Title (fr)
PROCÉDÉ POUR LE CALIBRAGE MÉCANIQUE DU POLYSILICIUM

Publication
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Application
EP 16711200 A 20160315

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Abstract (en)
[origin: WO2016202473A1] The object of the invention is a screen plate (1) for screen installations for mechanically classifying polysilicon, comprising a feeding zone (2) for polysilicon, a profiled region (3) with tips (32) and depressions (31), a region (4) with slots (41), the slots (41) adjoining the depressions (31), and a removal region (5), wherein the slots (41) increase in the direction of the removal region.

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DE 60310627 T2 20071011 - HEMLOCK SEMICONDUCTOR CORP [US]

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